

**INFORMATION DISCLOSURE CITATION**  
(Use several sheets if necessary)

Docket Number (Optional)

GGD-

Application Number

09/154,431

Applicant(s)

François Ménard and Louis Bélanger

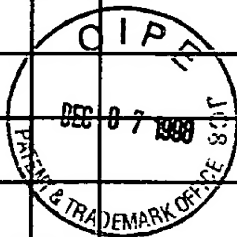
Filing Date

09/16/98

Group Art Unit

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
DD	A	5,563,938	10/08/98	Soshea et al.	379		
DD	B	5,751,706	05/12/98	Land et al.	370		



**FOREIGN PATENT DOCUMENTS**

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

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DATE CONSIDERED

7/23/01

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# INFORMATION DISCLOSURE CITATION

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Docket Number (Optional)

GGD-104

Application Number

09/154,431

Applicant(s)

MÉNARD, François

Filing Date

09/16/98

Group Art Unit

2743

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
DD	A	5,654,957	08/05/97	Koyama	370		
DD	B	5,661,785	08/26/97	Carpenter et al.	379		

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MAR 29 1999

Group 2700

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
DD	B	2,753 862	09/26/96	FRANCE				✓
DD	B	PCT/US/97/16504	09/12/97	WO				
DD	C	PCT/CA96/00460	07/10/96	WO				
DD	D	PCT/CA95/00147	03/16/95	WO				

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

DD		1997 Elsevier Science B.V., Microprocessors and Microsystems 21 (1997) 213-221

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